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Sheet 1 of 2


Application Number	N/A
Filing Date	Herewith
First Named Inventor	Christopher D.W. Jones
Group Art Unit	N/A 2814
Examiner Name	N/A HOAI PHAM
Attorney Docket Number	JONES 2-21-60

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		Application Number	N/A
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (use as many sheets as necessary)		Filing Date	Herewith
		First Named Inventor	Christopher D.W. Jones
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Sheet	2	of	2

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